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In the Patent Application of
Shedgao LIU et al.

Shedgao LIU et al.

Filed: January 23 2004

For: PHOTORESIST COMPOSITIONS COMPRISING DIAMONDOID DERIVATIVES

The Patent Application of MAIL STOP AMENDMENT

Shedgao LIU et al.

Group Art Unit: 1752

Examiner: Cynthia Hamilton

Confirmation No.: 9511

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 20, 2005, Applicants submit herewith the following Response:

Amendments to the specification begin on page 2 of this paper.

Amendment to the Drawings begin on page 3 of this paper.

Amendments to the claims begin on page 4 of this paper.

Remarks begin on page 16 of this paper.